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Rih Data Sheet

**CONFIRMATION NO. 9030** 

SERIAL NUMBER 10/069,058		FILING DATE 08/27/2002 RULE	CLASS GI 438		GR	GROUP ART UNIT 2814		ATTORNEY DOCKET NO. 4747-4600	
APPLICANTS  Thierry Barge, Grenoble, FRANCE; Andre Auberton-Herve, St. Egreve, FRANCE; Hiroji Aga, Annaka Gunma, JAPAN;Naoto Tate, Annaka Gunma, JAPAN;  *** CONTINUING DATA *********************** This application is a 371 of PCT/FR00/02330 08/17/2000  *** FOREIGN APPLICATIONS ************************************									
Foreign Priority claimed 35 USC 119 (a-d) conditions met Veriffed and Acknowledged  ADDRESS 28765 WINSTON & STRAWN LLP 1700 K STREET, N.W. WASHINGTON, DC 20006									
TITLE  Method for treating substrates for microelectronics and substrates obtained according to said method									
	No to charge/credit DEPOSIT ACCOUNT RECEIVED No for following:					All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit			